

2863



PATENT
941-306P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicants: Shun-An CHEN et al. Conf.: 1826

Serial No.: 09/930,971 Art Unit: 2863

Filed: August 17, 2001 Examiner: X. Sun

For: SYSTEM FOR DYNAMICALLY MONITORING THE STABILITY
OF SEMICONDUCTOR MANUFACTURING EQUIPMENT

LARGE-ENTITY TRANSMITTAL FORM

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

September

2003
SEP 22 2003
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Sir:

Transmitted herewith is a REQUEST FOR RECONSIDERATION in the above-identified application.

- The enclosed document is being transmitted via the Certificate of Mailing provisions of 37 C.F.R. §1.8.
- The enclosed document is being transmitted via facsimile.

The fee has been calculated as shown below:

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NUMBER PREVIOUSLY PAID FOR			PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	13	-	20	=	0	\$ 18	\$0.00
INDEPENDENT	1	-	3	=	0	\$ 84	\$0.00
<input type="checkbox"/> FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM						\$280	\$0.00
						TOTAL	\$0.00

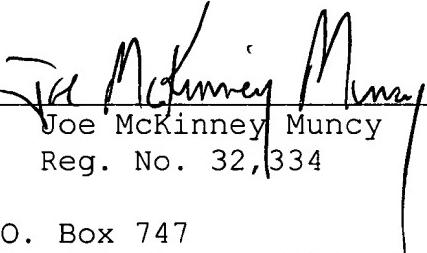
- Petition for () month(s) extension of time pursuant to 37 C.F.R. §§1.17 and 1.136(a). \$0.00 for the extension of time.
- No fee is required.
- Check(s) in the amount of \$0.00 is(are) enclosed.
- Please charge Deposit Account No. 02-2448 in the amount of \$0.00. This form is submitted in triplicate.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies to debit Deposit Account No. 02-2448 for any additional fee required under 37 C.F.R. §1.16 or §1.17, particularly extension of time fees, or to credit said Deposit Account for any overpayment of fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By


Joe McKinney Muncy
Reg. No. 32,334

941-306P
Attachment
KM:rk

P. O. Box 747
Falls Church, VA 22040-0747
(703) 205-8000



#10/Response
OK/ON
9/25/03

PATENT
941-306P

IN THE U. S. PATENT AND TRADEMARK OFFICE

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OF SEMICONDUCTOR MANUFACTURING EQUIPMENT

REQUEST FOR RECONSIDERATION

Assistant Commissioner for Patents
Washington, DC 20231

September 16, 2003

Sir:

In response to the Office Action mailed June 16, 2003 (Paper No. 9), the following remarks are respectfully submitted in connection with the above-identified application:

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